

## **DuPont™ EKC Technology**

Wafer Level Packaging Photoresist Remover

For Complete Resist Removal

#### **Product Description**

WLP photoresist removers are formulations optimized to effectively remove thick negative liquid resists used for wafer bumping by solder electroplating or stencil printing. The product is designed for use in spray processing equipment and wet benches.

#### **Features**

- Formulated to give complete resist removal and eliminate resist re-deposit
- Short stripping time requirement
- High wafer capacity with long bathlife
- Compatible with wet bench and spray process equipment
- Operates at moderate temperatures
- Low evaporation rate at operating temperature
- Completely water rinsable
- High flashpoint
- Compatible with copper and a wide variety of under-bump metallization (UMB materials)
- Compatible with conventional and lead-free solders

### **Benefits**

- No polymer residues around bumps
- Eliminates UBM etch masking
- Offers flexibility in equipment choice
- · Higher throughput
- Resource conservation through reduced stripping time and temperature
- Reduced material use and disposal from less frequent bath or tank changes
- Lower overall operating costs



After PR Removal



After PR Removal



Before PR Removal



After PR Removal



# For more information on $DuPont^{m}$ EKC Technology or other DuPont products, please visit our website.

**ekctech.dupont.com**The information provided in this data sheet corresponds to our knowledge on the subject at the date of its publication. It may be subject to revision as new knowledge and experience becomes available. This information is not intended to substitute for any testing you may need to conduct to determine for yourself the suitability of our products for your particular purposes. Since we cannot anticipate all variations in end-use and disposal conditions, DuPont makes no warranties and assumes no liability in connection with any use of this information. It is intended for use by persons having technical skill, at their own discretion and risk. Nothing in this publication is

to be considered as a license to operate under or a recommendation to infringe any patent right.

**CAUTION:** Do not use in medical applications involving permanent implantation in the human body. For other medical applications, see "DuPont Medical Caution Statement," H-50102-5 and "DuPont Policy Regarding Medical Applications" H-50103-5.

DuPont", the DuPont Oval Logo, and all products, unless otherwise noted, denoted with M, SM or 8 are trademarks, service marks or registered trademarks of affiliates of DuPont de Nemours, Inc. © 2019 DuPont de Nemours, Inc. All rights reserved.

K-10752-3 (05/19)